

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Aaron PARTRIDGE et al.
 Serial No. : 10/713,172
 Filing Date : November 14, 2003
 For : CRACK AND RESIDUE FREE CONFORMAL
 DEPOSITED SILICON OXIDE WITH
 PREDICTABLE AND UNIFORM ETCHING
 CHARACTERISTICS
 Examiner : Francis P. Smith
 Group Art Unit : 1792
 Confirmation No. : 9823
Customer No. : 26646

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 Commissioner for Patents
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I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on April 6, 2009.

Signature: /Aaron Grunberger/
 Aaron Grunberger (Reg. No. 59,210)

SUPPLEMENTAL AMENDMENT AFTER FINAL OFFICE ACTION

SIR:

In response to the Final Office Action of November 7, 2008, please reconsider the above-identified application based on the following¹.

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

¹ This supplements the Amendment filed February 17, 2009, and differs from said Amendment in that it amends claims 4, 44, and 51 to be in independent form without changing the scope of any of the claims. The amendments to the claims thus place the application in better form for appeal and should be entered.